The embodiments of the invention in which an exclusive property or privilege is claimed are defined as follows:

- 1. A semiconductor inverter comprising:
- a semiconductor substrate;
- an insulator formed on said semiconductor substrate;
- a semiconductor layer formed on said insulator;
- a p-well formed in said semiconductor layer, said p-well being the output of said inverter;
- a gate structure formed atop said p-well, said gate structure being the input of said inverter and being formed from a thin gate oxide layer underneath a conductive layer;
 - an n- base formed adjacent to a first edge of said gate structure;
 - a p+ structure formed within said n- base; and
 - a n+ structure adjacent a second edge of said gate structure.
- 2. The inverter of Claim 1 wherein said p-well extends through said semiconductor layer to said insulator.
- 3. The inverter of Claim 1 wherein said p+ structure and said n+ structure extend through said semiconductor layer to said insulator.
- 4. The inverter of Claim 1 wherein said semiconductor layer is less than 1500 angstroms thick.
- 5. The inverter of Claim 1 wherein said p- well is the output of said inverter.
 - 6. A semiconductor inverter comprising
 - a semiconductor substrate;
 - an insulator formed on said semiconductor substrate;
 - a semiconductor layer formed on said insulator;
- an n-well formed in said semiconductor layer, said n-well being the output of said inverter:

a gate structure formed atop said n-well, said gate structure being the input of said inverter and being formed from a thin gate oxide layer underneath a conductive layer;

an p-base formed adjacent to a first edge of said gate structure;

- a n+ structure formed within said p- base; and
- a p+ structure adjacent a second edge of said gate structure.
- 7. The inverter of Claim 6 wherein said n-well extends through said semiconductor layer to said insulator.
- 8. The inverter of Claim 6 wherein said p+ structure and said n+ structure extend through said semiconductor layer to said insulator.
- 9. The inverter of Claim 6 wherein said semiconductor layer is less than 1500 angstroms thick.
- 10. The inverter of Claim 6 wherein said n- well is the output of said inverter.
- 11. A NAND logic circuit having a first input and a second input comprising:
 - a semiconductor substrate;
 - an insulator formed on said semiconductor substrate;
 - a semiconductor layer formed on said insulator;
 - a p-well formed in said semiconductor layer;
- a first gate structure formed atop said p-well, said first gate structure being the first input and being formed from a thin gate oxide layer underneath a conductive layer;
- a second gate structure formed atop said p-well, said first gate structure being the second input and being formed from a thin gate oxide layer underneath a conductive layer;
- a p+ structure formed adjacent to a first edge of said first gate structure and said second gate structure, said p+ structure being the output of said NAND logic circuit;
- a n+ structure adjacent a second edge of said first gate structure and said second gate structure;

a first switch formed in said semiconductor layer, said first switch electrically connected to said first input;

a second switch formed in said semiconductor layer in series to said first switch and electrically connected to said second input, said second switch also electrically connected to said p+ structure.

- 12. The NAND gate of Claim 11 wherein said p-well extends through said semiconductor layer to said insulator.
- 13. The NAND gate of Claim 11 wherein said p+ structure and said n+ structure extend through said semiconductor layer to said insulator.
- 14. The NAND gate of Claim 11 wherein said semiconductor layer is less than 1500 angstroms thick.
- 15. A NAND logic circuit having a first input and a second input comprising:

a semiconductor substrate;

an insulator formed on said semiconductor substrate;

a semiconductor layer formed on said insulator;

a n-well formed in said semiconductor layer;

a first gate structure formed atop said n-well, said first gate structure being the first input and being formed from a thin gate oxide layer underneath a conductive layer;

a second gate structure formed atop said n-well, said first gate structure being the second input and being formed from a thin gate oxide layer underneath a conductive layer;

a n+ structure formed adjacent to a first edge of said first gate structure and said second gate structure, said n+ structure being the output of said NAND logic circuit:

a p+ structure adjacent a second edge of said first gate structure and said second gate structure;

a first switch formed in said semiconductor layer, said first switch electrically connected to said first input;

a second switch formed in said semiconductor layer in series to said first switch and electrically connected to said second input, said second switch also electrically connected to said n+ structure.

- 16. The NAND gate of Claim 15 wherein said n-well extends through said semiconductor layer to said insulator.
- 17. The NAND gate of Claim 15 wherein said p+ structure and said n+ structure extend through said semiconductor layer to said insulator.
- 18. The NAND gate of Claim 15 wherein said semiconductor layer is less than 1500 angstroms thick.
- 19. A NOR logic circuit having a first input and a second input comprising:

a semiconductor substrate;

an insulator formed on said semiconductor substrate;

a semiconductor layer formed on said insulator;

a p-well formed in said semiconductor layer;

a first gate structure formed atop said p-well, said first gate structure being the first input and being formed from a thin gate oxide layer underneath a conductive layer;

a second gate structure formed atop said p-well, said first gate structure being the second input and being formed from a thin gate oxide layer underneath a conductive layer;

an n- base formed adjacent to a first edge of said first gate structure and said second gate structure;

a p+ structure formed within said n- base;

a second p+ structure adjacent a second edge of said first gate structure and said second gate structure, said second p+ structure being the output of said NOR logic circuit;

a first switch formed in said semiconductor layer, said first switch electrically connected to said first input; and

a second switch formed in said semiconductor layer in series to said first switch and electrically connected to said second input, said second switch also electrically connected to said second p+ structure.

- 20. The NOR gate of Claim 19 wherein said p-well extends through said semiconductor layer to said insulator.
- 21. The NOR gate of Claim 19 wherein said p+ structure and said n+ structure extend through said semiconductor layer to said insulator.
- 22. The NOR gate of Claim 19 wherein said semiconductor layer is less than 1500 angstroms thick.
- 23. A NOR logic circuit having a first input and a second input comprising:
 - a semiconductor substrate;
 - an insulator formed on said semiconductor substrate;
 - a semiconductor layer formed on said insulator;
- a n-well formed in said semiconductor layer, said n-well being the output of said NOR gate;
- a first gate structure formed atop said n-well, said first gate structure being the first input and being formed from a thin gate oxide layer underneath a conductive layer;
- a second gate structure formed atop said n-well, said first gate structure being the second input and being formed from a thin gate oxide layer underneath a conductive layer;
- an p+ structure formed adjacent to a first edge of said first gate structure and said second gate structure;
- a second p+ structure adjacent a second edge of said first gate structure and said second gate structure, said second p+ structure being the output of said NOR logic circuit;
- a first switch formed in said semiconductor layer, said first switch electrically connected to said first input; and
- a second switch formed in said semiconductor layer in series to said first switch and electrically connected to said second input, said second switch also electrically connected to said second p+ structure.
- 24. The NAND gate of Claim 23 wherein said n-well extends through said semiconductor layer to said insulator.

- 25. The NAND gate of Claim 23 wherein said p+ structure and said second p+ structure extend through said semiconductor layer to said insulator.
- 26. The NAND gate of Claim 23 wherein said semiconductor layer is less than 1500 angstroms thick.